



Attorney Docket No. 069974-0143

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Keiichiro KATA et al.
Title: PROCESS FOR MANUFACTURING SEMICONDUCTOR DEVICE
AND SEMICONDUCTOR WAFER
Application No.: 10/645,782
Filing Date: 8/22/2003
Examiner: Mark Prenty
Art Unit: 2822

AMENDMENT AND REPLY UNDER 37 C.F.R. 1.173

Mail Stop Amendment
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This amendment and reply is being filed in response to a final Office Action dated May 23, 2006, for the above-identified application.

Amendments to the Claims begin on page 2 of this document.

Remarks/Arguments begin on page 6 of this document.

Please amend the application as follows: